

Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty D cket No. SUN1P507/P4152	Application No.: 09/465,994
	Applicant: Ye, et al.	
	Filing Date 12-16-1999	Group 2121

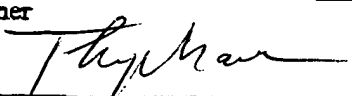
U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub- class	Filing Date
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Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub- class	Translation	
							Yes	No
TP	B1	EP0524071A1	January 20, 1993	EP	G06F	9/46	X	
TP	B2	EP0908821A1	April 14, 1999	EP	G06F	9/455		X

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1	<u>Second Office Action</u> issued July 9, 2004, for Chinese Patent Application No. 00810268.6, filed July 13, 2000 , <i>Methods and Apparatus For Managing An Application According To an Application Lifecycle.</i>
Examiner 		Date Considered 2/2/05

Examiner: Initial citation considered. Draw line through citation if not in conformance, and not considered. Include copy of this form with next communication to applicant.